IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

the Application of: Norio FUKASAWA et al.

Group Art Unit: 2827

Serial Number: 09/029,608

Examiner: David E. Graybill

Filed: May 15, 1998

Confirmation No.: 6285

For: METHOD AND MOLD FOR A MANUFACTURING SEMICONDUCTOR DEVICE, SEMICONDUCTOR DEVICE, AND A METHOD FOR MOUNTING THE DEVICE

Attorney Docket No.: 980233

Customer No.: 38834

INFORMATION DISCLOSURE STATEMENT WITH STATEMENT PURSUANT TO 37 CFR 1.97(c)

Attn: Group Director

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: March 11, 2004

Sir:

The attention of the Patent and Trademark Office is hereby directed to the document listed on the attached Form PTO-1449. A copy of the document is attached along with a Korean Office Action dated January 31, 2004, with a Japanese translation, thereof (an English translation is not readily available).

This Information Disclosure Statement is being submitted after the issuance of a first official action on the merits and expiration of the three month period following the filing date or the entry in the national stage for the above-captioned application, but prior to the issuance of either a Final Office Action, Notice of Allowance, or an action that otherwise closes prosecution in the application.

Information Disclosure Statement

Serial No.: 09/029,608

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The undersigned hereby states that each item of information contained in this statement

was first cited in any communication from a foreign patent office in a counterpart foreign

application not more than three months prior to the filing of this statement.

The above information is presented so that the Patent and Trademark Office can, in the first

instance, determine any materiality thereof to the claimed invention. See 37 CFR 1.104(a)

concerning the PTO duty to consider and use any such information. It is respectfully requested that

the information be expressly considered during the prosecution of this application, and that the

documents cited in the attached Form PTO-1449 be made of record therein and appear on the first

page of any patent to issue therefrom.

The Commissioner is hereby authorized to charge any additional fee (or credit any

overpayment) associated with this Statement to our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

Attorney for Applicants

Reg. No. 32,878

SGA/ww

Enclosure:

PTO 1449

One (1) Reference

Korean Office Action

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INFORMATION
DISCLOSURE
<b>STATEMENT</b>
PTO-1449

Attv. Docket No. 980233 Serial No. 09/029.608

Applicant(s): FUKASAWA et al.

Filing Date: May 15, 1998 Group Art Unit: 2827

## **U.S. PATENT DOCUMENTS**

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
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## FOREIGN PATENT DOCUMENTS

Examiner Initial	Document		Date	Country	Translation (Yes – Abstract)
		KR 1994-18951	8/19/1994	KR	
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## **OTHER DOCUMENTS**

Examiner	Date Considered